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**** CONTINUING DATA *******
 This application is a 371 of PCT/JP03/16818 12/25/2003

**** FOREIGN APPLICATIONS *******
 JAPAN 2002-380558 12/27/2002

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| Foreign Priority claimed 35 USC 119(a-d) conditions met | <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | <input type="checkbox"/> Met after Allowance | STATE OR COUNTRY | SHEETS DRAWINGS | TOTAL CLAIMS | INDEPENDENT CLAIMS |
| Verified and Acknowledged | /MAKI A ANGADI/ Examiner's signature | Initials | JAPAN | 12 | 13 | 3 |

ADDRESS
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TITLE
 Method and device for plasma-etching organic material film

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